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AMENDMENTS TO THE CLAIMS

1. (Currently Amended) A light emitting device, comprising:

a GaN based layer;

a high concentration GaN-based layer formed on the GaN-based layer;

a first conductive semiconductor layer;

an active layer formed on the first conductive semiconductor layer;

a second conductive semiconductor layer formed on the active layer;

a high concentration GaN-based semiconductor layer formed on the second conductive

semiconductor layer;

a first metal-Ga compound layer formed on the high concentration GaN-based

semiconductor layer;

a first metal layer formed on the first metal-Ga compound layer;

a third metal-Al compound layer formed on the first metal layer; and

a conductive oxidation preventive layer formed on the third metal-Al compound layer.

2-3. (Cancelled)

4. (Currently Amended) The light emitting device according to claim 1, wherein the

second conductive semiconductor layer is a GaN-based layer is P-type or N-type GaN-based

<u>layer</u>.

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5. (Currently Amended) The light emitting device according to claim 1, wherein the first

metal layer is of one selected from the group consisting of Cr, V and W.

6. (Cancelled)

7. (Currently Amended) The light emitting device according to claim 1, wherein the third

metal is of one selected from the group consisting of Ni, Pt and Pd.

8. (Currently Amended) The light emitting device according to claim 1, wherein the third

metal is of a metal or compound having a high reactivity with Al.

9. (Cancelled)

10. (Currently Amended) The light emitting device according to claim 1, wherein the

conductive oxidation preventive layer is of Au, or is of a multi-metal or compound of two or

more kinds containing Au.

11-52. (Cancelled)

53. (Currently Amended) The light emitting device according to claim 1, wherein the first

conductive semiconductor layer is an N-type layer, and the second conductive semiconductor

layer and the high concentration GaN-based semiconductor layer are P-type layers.

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light device comprises an NP-type light emitting device or an NPN-type light emitting

device.

54. (Currently Amended) The light emitting device according to claim 1, wherein the first

metal layer is of one selected from the group consisting of Cr, V and W, and the third metal is of

one selected from the group consisting of Ni, Pt and Pd.

55. (Currently Amended) The light emitting device according to claim 1, comprising a

transparent electrode layer formed between the high concentration GaN-based semiconductor

layer and the first metal-Ga compound layer.

56. (Currently Amended) The light emitting device according to claim 55, wherein the

high concentration GaN-based layer is a P-type or N-type layer.

57. (Currently Amended) The light emitting device according to claim 55, wherein the

first metal layer is of one selected from the group consisting of Cr, V and W, and the third metal

is of one selected from the group consisting of Ni, Pt and Pd.

58. (New) The light emitting device according to claim 1, wherein the first metal-Ga

compound layer, the first metal layer, the third metal-Al compound layer, and the conductive

oxidation preventive layer form an electrode.

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59. (New) The light emitting device according to claim 1, wherein the first conductive

semiconductor layer comprises at least one of an Al material or an In material.

60. (New) The light emitting device according to claim 57, wherein the conductive

oxidation preventive layer comprises one of Au, a multi-metal, and a compound of two or more

kinds containing Au.

61. (New) The light emitting device according to claim 53, wherein the second

conductive semiconductor layer comprises a vacancy structure.

62. (New) The light emitting device according to claim 1, wherein the third metal-Al

compound layer is a metal layer.

63. (New) The light emitting device according to claim 1, wherein a high concentration

GaN-based semiconductor layer comprises a carrier concentration of more than 10¹⁸cm⁻³.

64. (New) The light emitting device according to claim 1, wherein a high concentration

GaN-based semiconductor layer comprises a carrier concentration more than a carrier

concentration of the second type conductive semiconductor layer.

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